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13-Dec-2024

Journal: ACS Applied Electronic Materials

Manuscript ID: el-2024-021387

Title: "Fabrication of highly ordered macropore arrays in p-type silicon by electrochemical etching: effect of wafer resistivity and etching parameters"

Author(s): Zhang, Jing; Zhang, Faqiang; Ma, Mingsheng; Liu, Zhifu

Dear Dr. Quiroga-González:

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Sincerely,

Prof. Paz Vaqueiro  
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